

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1322		SERIAL NO. 09/512,149		
CIPR JAN 16 2003 PTO-1449		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT Vishnu K. Agarwal				
		FILING DATE February 23, 2000		GROUP 2814					
U.S. PATENT DOCUMENTS									
Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
NSP	AA	5,438,012	08/01/95	Kamiyama					
	AB	6,090,659	07/18/00	Laibowitz et al.					
	AC	3,886,415	05/27/75	Genthe					
	AD	5,665,210	09/09/97	Yamazaki					
	AE	5,675,028	10/07/97	Neumayer et al.					
	AF	5,723,382	03/03/98	Sandhu et al.					
	AG	5,858,873	01/12/99	Vitkavage et al.					
	AH	6,028,359	02/22/00	Merchant et al.					
	AI	6,081,034	06/27/00	Sandhu et al.					
	AJ	5,580,812	12/03/96	Ikemasu et al.					
NSP	AK	3,210,607	10/05/65	Flanagan					
NSP	AL	6,165,833	12/26/00	Parekh et al. (08/994,054)					
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
								Yes	No
NSP	AM	WO97 44797	11/27/97	PCT					
NSP	AN	JP405243524A	09/21/93	Japan					
NSP	AO	JP406061449A	03/04/94	Japan					
	AP								
	AQ								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
NSP	AR	Ghandhi, Sorab K., "VLSI Fabrication Principles - Silicon and Gallium Arsenide," ©1994 by John Wiley & Sons, Inc., pages 522-523 (4 total pages).							
NSP	AS	Jaeger, Richard C., "Volume V - Introduction to Microelectronic Fabrication," ©1988 by Addison-Wesley Publishing Company, Inc., page 116 (3 total pages).							
NSP	AT	Wolf et al., "Silicon Processing for the VLSI Era - Volume 1: Process Technology," ©1986 by Lattice Press, pages 335, 336, 348-353 (10 total pages).							
EXAMINER		DATE CONSIDERED 3/4/03							

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U.S. PATENT DOCUMENTS						
Examiner	Document Number	Date	Name		Class	Subclass
MM	AA 5,843,830 ✓	12/01/98	Graettinger et al. (08/670,644)			
	AB 5,786,248 ✓	07/28/98	Schuegraf (08/542,430)			
	AC 5,910,880 ✓	06/08/99	DeBoer et al. (08/916,771)			
	AD 6,191,443 B1 ✓	02/20/01	Al-Shareef et al. (09/033,063)			
	AE 6,162,744 ✓	12/19/00	Al-Shareef et al. (09/033,064)			
	AF 6,156,638 ✓	12/05/00	Agarwal et al. (09/058,612)			
	AG 6,255,186 B1 ✓	07/03/01	Al-Shareef et al. (09/137,780)			
	AH 6,165,834 ✓	12/26/00	Agarwal et al. (09/074,638)			
	AI 5,985,714 ✓	11/16/99	Sandhu et al. (08/858,027)			
	AJ 5,955,758 ✓	09/21/99	Sandhu et al. (08/738,789)			
MM	AK 6,017,789 ✓	01/25/00	Sandhu et al. (08/881,561)			
MM	AL 6,198,124 B1 ✓	03/06/01	Sandhu et al. (09/086,389)			
FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Subclass	Translation
						Yes
	AM					No
	AN					
	AO					
	AP					
	AQ					
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
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U.S. PATENT DOCUMENTS									
Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
AA		6,071,771	06/06/00	Schuegraf (09/122,473)					
AB		6,146,959	11/14/00	DeBoer et al. (09/098,035)					
AC		6,171,925 B1	01/09/01	Graettinger et al. (09/185,412)					
AD		6,282,080 B1	08/28/01	DeBoer et al. (09/229,518)					
AE									
AF									
AG									
AH									
AI									
AJ								04/10/98	
AK								05/21/98	
AL									
FOREIGN PATENT DOCUMENTS									
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								Yes	No
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AN									
AO									
AP									
AQ									
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
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EXAMINER				DATE CONSIDERED					
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